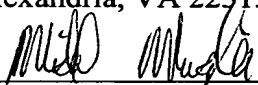




IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Serial No. : 10/739,229)	Date of Deposit:
Confirmation : 1123)	July 8, 2005
)	
Applicants : CHO, Byoung H.)	I hereby certify that this paper and the
Filed : December 18, 2003)	documents referred to therein are being
)	deposited with the United States Postal Service
Title: METHOD FOR FORMING)	with sufficient postage, as first class mail, in an
GATE OXIDE IN SEMICONDUCTOR)	envelope addressed to:
DEVICE)	Mail Stop ISSUE FEE
)	Commissioner for Patents
Art Unit : 2818)	P.O. Box 1450
Examiner : NHU, David)	Alexandria, VA 22313-1450
)	
Atty Docket : 29936/39870)	
Customer No. : 04743)	Michael Muczynski

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is responsive to the "Reasons for Allowance" in the Notice of Allowance and Fee(s) Due dated June 13, 2005, and is submitted under 37 C.F.R. § 1.104(e).

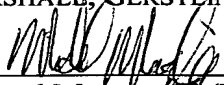
Consistent with MPEP 2111, during examination the U.S. Patent and Trademark Office has given the claims their broadest reasonable interpretation as they would be understood by one of ordinary skill in the art. In addition to the reasons set forth in the allowance papers, it is respectfully submitted that the claims are allowable for the additional reasons that the invention defined by the language of the claims is neither anticipated by, nor would have been obvious when taken as a whole in view of, the art of record.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

July 8, 2005

By


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